

Docket No.: 50099-184

# 6  
IDS  
PATENT 3.27.03  
aff

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Masato FUJINAGA

Serial No.:

Group Art Unit:

Filed: October 16, 2001

Examiner:

For: HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.


This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No.:

The relevance of each non-English language reference, if any, is discussed in the present specification.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

  
Stephen A. Becker  
Registration No. 26,527

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 SAB:mlw  
**Date: October 16, 2001**  
Facsimile: (202) 756-8087